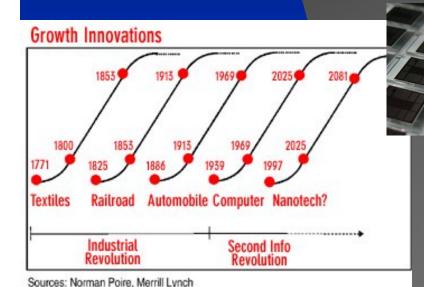
Using new international patented production technologies for polymer mems and high-integrated systems

Micromechanics, MEMS, Plastic Lab-on-a-chip Production Service, Packaging and R&D Advanced Micro- and Nanotechnologies International Patented Technologies: RMPD® Rapid Micro Product Development 3D-CSP 3-dimensional Chip Size Packaging From the Idea to the Series Production

World Market of MEMS based electronics: 7 Mrd. today, growth >20% per year





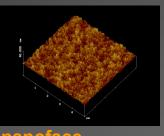
#### **RMPD® - Technologies**

multimat









nanoface

**Assembly** 







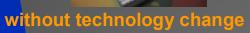


3D-CSP



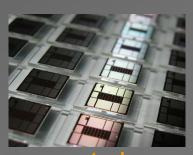
~











no tools

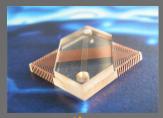


**Parallel batch production** 

microFLUIDIC



with light



coating



#### microTEC business today

## Contract Manufacturing and Contract R&D (licenses and training available for special fields)

•Micromechanics, MEMS Packaging Services and R&D Services Highly integrated products speed up the need of 3D-packaging technologies. This will become a fast growing market for patented 3D-CSP processes.

•Customized polymer parts like Lab on a chip, customized series production of polymerchips and components used in industry benefit from international patented RMPD ®-technologies

RMPD® Systems are easy to use and easy to maintain =>Fast deliverable series parts in flexible units in high precision at low cost

3D-CSP batch process is fast and cost efficient by parallel connecting pads

Easy to handle materials (fluid monomers/polymers) =>no high-risk chemicals

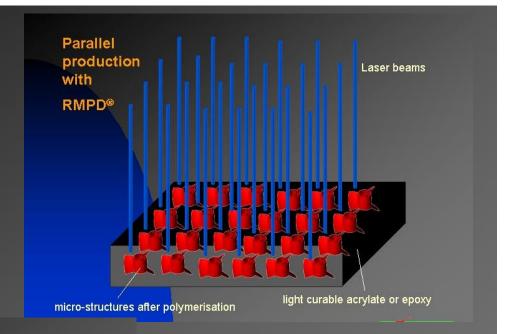
Every 3D-CAD Software can be used (\*.stl/\*.iges/\*.step a.s.o)

Direct Integration of microelectronic CAD (OrCAD) into Design

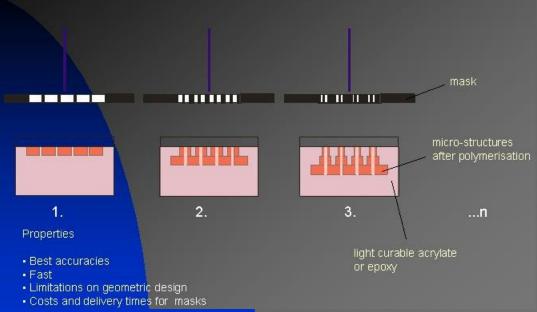
Simulation and direct series production of multi material systems!



# Generative processes for microstructures and -systems



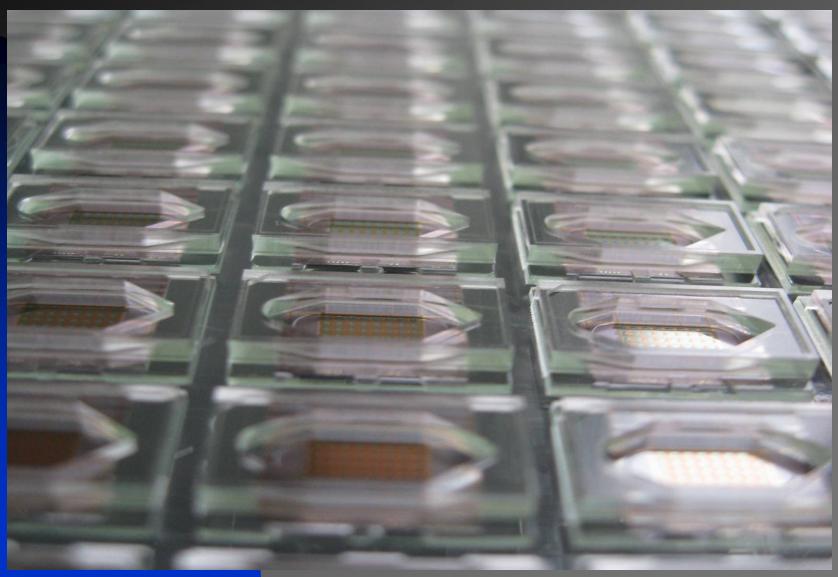
#### Structures with RMPD®-mask





© microTEC Gesellschaft für Mikrotechnologie mbH 1996-2008

## Parallel batch production by RMPD®



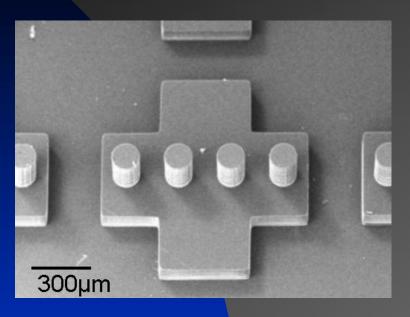


#### RMPD®-mask batch





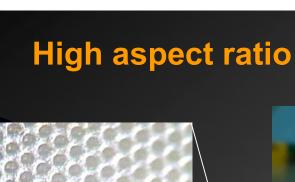
## **Typical structure for mass production**

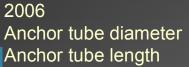




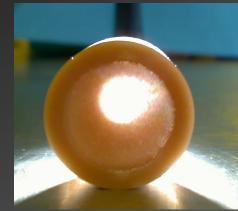
- series production without tooling
- RMPD®-mask allows production runs up to 1.000.000 parts per machine and hour
- Mass production with 5", 9", 14" and 350 mm mask
- Outlook: 610 mm and RMPD®-Rotation

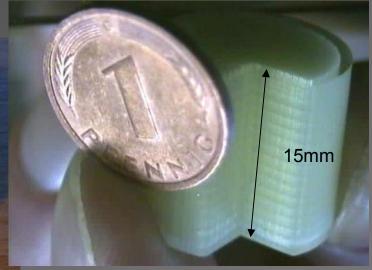






200 μm  $20.000 \ \mu m$ Distance between holes 50 µm







1997

Anchor tube diameter 150 µm Anchor tube length 15.000 µm Distance between holes 70 µm

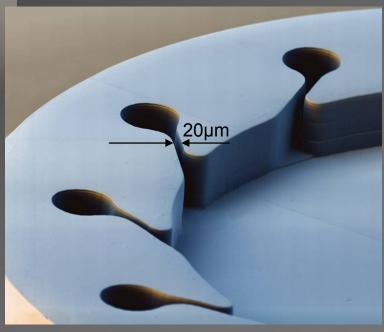


# **Component for Medical Applications, Micro Heat Engines and other applications**



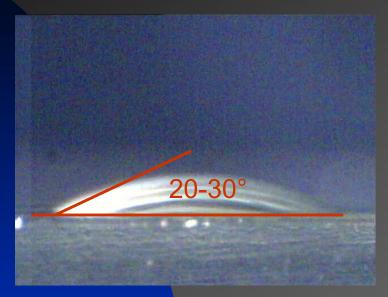
Nozzle plate for driving head

- Diameter = 4 mm
- Nozzle width = 20 μm

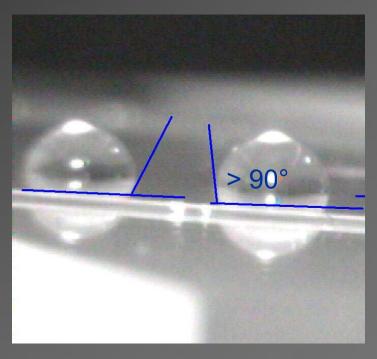




## Micro-fluidic applications: Intrinsic hydrophilic and hydrophobic material properties require no coating



Hydrophilic materials for: Capillary flow enhancement



Hydrophobic material for Dispensing units
Nozzle structures
Surface protection

smart spotting



#### Fluidic- stop structure, as ventilation duct

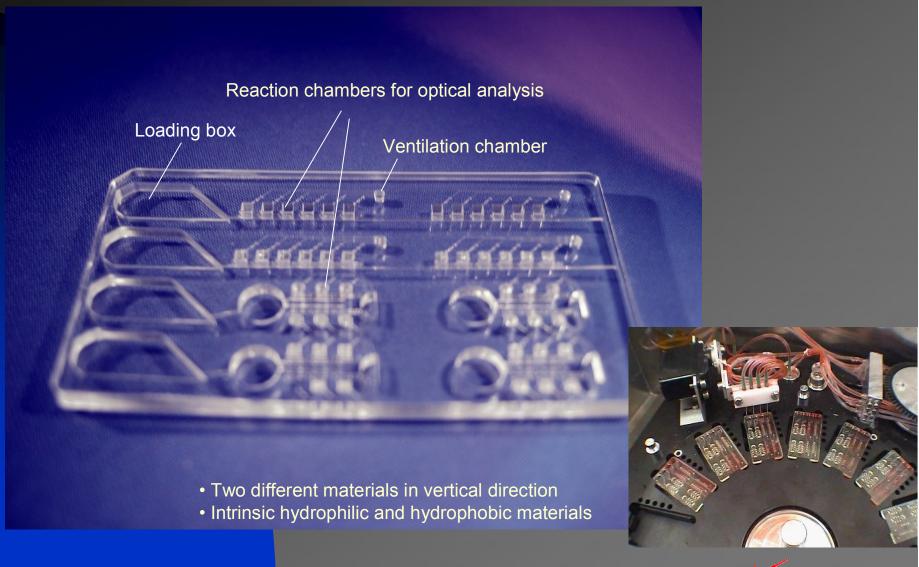
#### **Principle:**

Gases pass through Liquids are blocked Applications: - Ballpoint pen - Air vent ampule 50 µm 3.000 µm 30 µm 60 3 mm 50µm

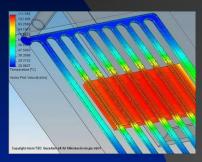
Tube diameter Tube length Distance between holes Aspect ratio

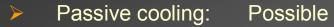


#### Microfludic chips, automaticially processed for analysis



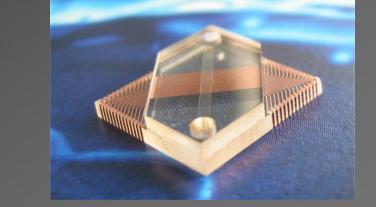
#### > 3D-CSP NMRC Thermal Simulation





Option: Active cooling via EHD pump





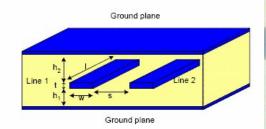






Full selected 3D CAD structure

Frequency range: 100 MHz ... 8,5 GHz



Structure cross-section

 $R = 0.118\Omega/mm$ 

L= 0.34nH/mm

C = 0.063 pF/mm

G= 3 10<sup>-8</sup> S/mm

k: Distance 25um - k=0.083

25µm

Distance 50um - k = 0.02

Distance 75um - k=0.005

4 interconnection - and shielding layers and 6 isolation layers

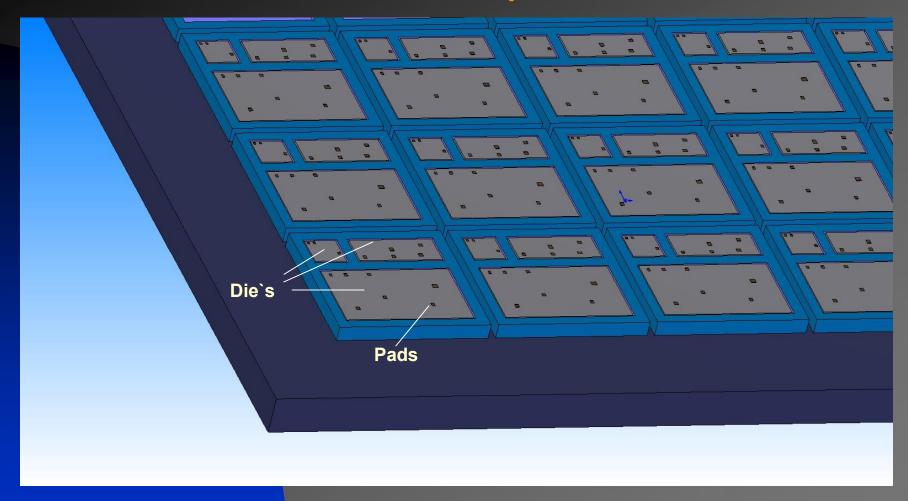




4 Step Process to build MEMS

- 1. RMPD® -Mask
- 2. Placement of inserts
- 3. Metallisation
- . Metal Layer structuring

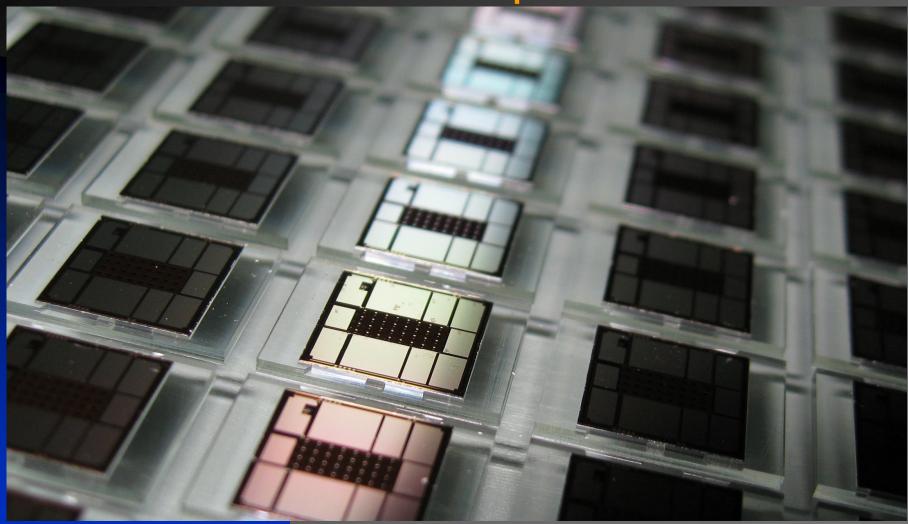




4 Step Process to build MEMS

- 1. RMPD® -Mask
- 2. Placement of inserts
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- Metal Layer structuring

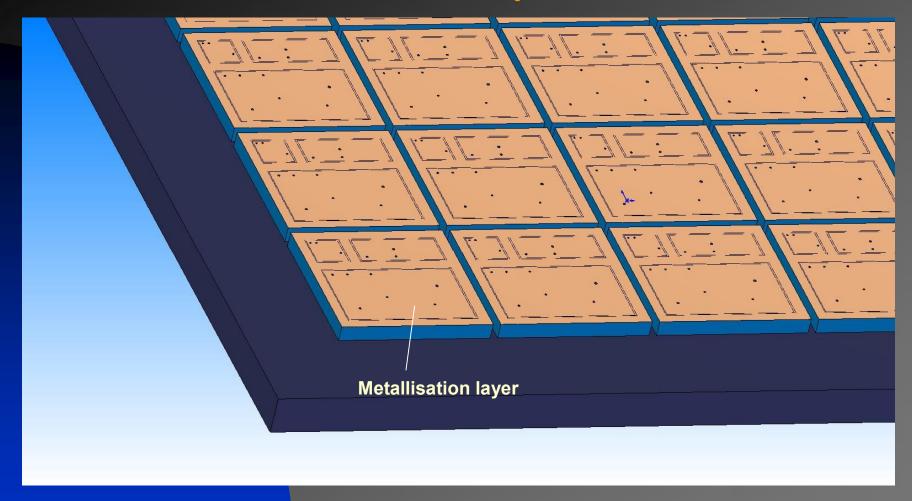




4 Step Process to build MEMS

- 1. RMPD® -Mask
- 2. Placement of inserts
- 3. Metallisation
- L. Metal Layer structuring

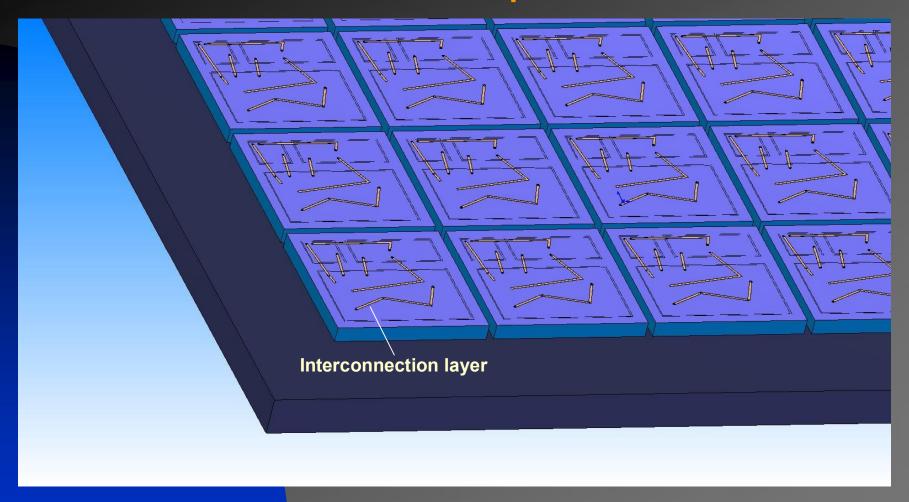




4 Step Process to build MEMS

- 1. RMPD® -Mask
- 2. Placement of inserts
- 3. Metallisation
- 4. Metal Layer structuring





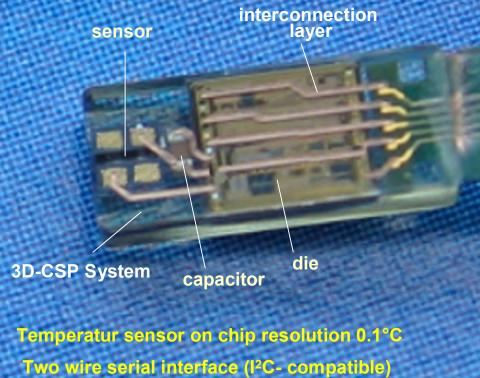
4 Step Process to build MEMS

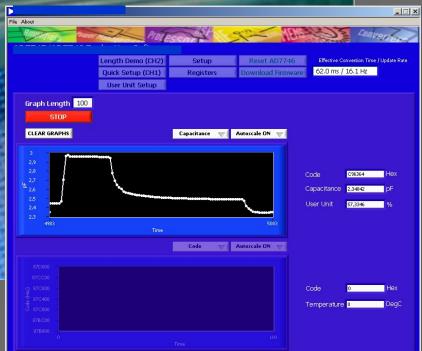
- 1. RMPD® -Mask
- 2. Placement of inserts
- 3. Metallisation
- 4. Metall Layer structuring



## Sensor with 24-Bit Capacitance – to Digital Converter

Technology: 3D-CSP with RMPD® ,special sensor adaptation with low interferences



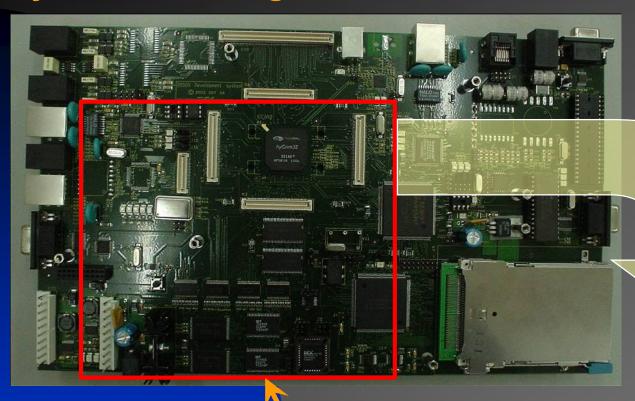


**Connected PCB flex circuit** 

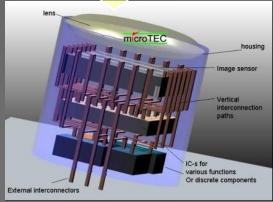




## System-in-Package Solutions based on 3D-CSP



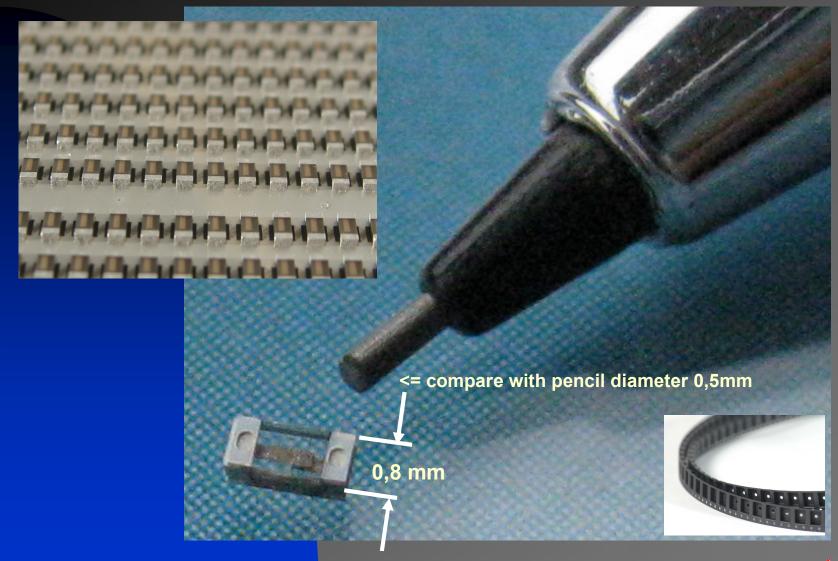
Only processor and networking subsystem!







## 3D-CSP die housing for SMD case sizes 0603 and less







#### **Customers Advantages:**

- One stop shop (full service: consulting, R&D, series production)
- •Unique and patented technologies (IP security to customers), microTEC technologies and products are protected by patents, some of them are worldwide
- Capability to integrate market and customer needs very early in product development but without additional costs (CAD to series product) and Speeding up time to market (no tooling)

#### **Image and Database:**

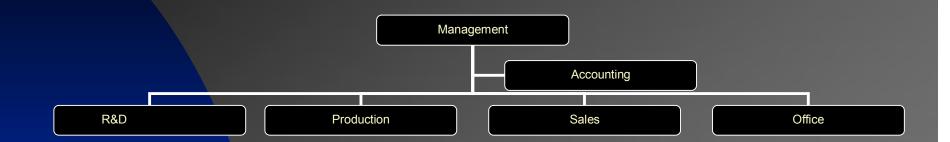
microTEC is well known as technology and innovation leader, in 12 years we build up a database of more than 20thousand qualified decision makers with interest in MEMS and nanotechnologies. microTEC sales today is focussing 80 companies. Our trademark is international protected too.

microTEC Website:

More than 60thousand visitors from 45 countries every year



#### **Organisation**



#### **Management:**

A. Reinhardt, R. Götzen, H. Bohlmann

#### Team:

high qualified employees, >50% Engineering degree

#### Shareholder:

48% =IKB Equity Fund I - IKB Deutsche Industriebank AG
52% =(Dr. U. Bittner, Dr. Ing. H. Bohlmann, Dipl. Ing. R. Götzen, A. Reinhardt, Dipl. Ing. J. Rost)



#### **Management and Advisory Board**

Dipl. Ing. Reiner Götzen, CEO/CTO

Inventor and founder of microTEC. He worked as scientist at University Duisburg, technical designer photo systems at Robot GmbH Düsseldorf and started his career at Thyssen Krupp AG in the field of precision mechanics. Mr. Götzen is working for microTEC since 1996 and is the driver of the innovations realized in the last 12 years, particular the international patented production technologies and the customer projects.

#### Andrea Reinhardt, CEO/CFO

Educated at University Mannheim she worked in leading position at Real-Film Ludwigshafen and started her career in Banking Citibank Mannheim and DGZ Bank Frankfurt. She is working for microTEC since 1996, with focus on business development. Mrs. Reinhardt is co-founder of NTC Nano Tech Coatings GmbH, is active as evaluator for EC and national projects, is part of the European Platform of Micro- and Nanotechnologies MINAM as member of the industrial board and at the public private partnership ZIRP <a href="www.zirp.de">www.zirp.de</a>.

Dr. Ing. Helge Bohlmann, Power of attorney, project manager EC and sales He worked as a scientist at University Hannover, as project manager for IVAM and as sales manager for UBM measuring systems. Dr. Bohlmann is working for microTEC since 2000 and is taking care of the EC funded projects and key customers.

#### **Advisory Board**

Dr. Lutz-Dieter Thiele: worked in top management positions at Omron Europa GmbH and Linotype-Hell AG. He is working as management consultant today.

Dr. Udo Bittner: worked in management positions at Siemens AG, Start Amadeus Itd, Deutsche Post AG he is now working for Thomas Cook AG in a position of higher management.

Dr. Udo Sonnhof, Founder and Managing Director of SPI GmbH, Robotics and Optical Systems;



#### microTEC

Gesellschaft für Mikrotechnologie mbH

Thank you for your attention, don't hesitate to contact us for details!

Andrea Reinhardt +496322650220 Reiner Götzen +492033062050 http://www.microTEC-D.com

